## End semester University Practical Examinations October/ November 2018

Department of Chemical Engineering SRM Institute of Science and Technology Kattankulathur - 603 203

## Practical Exam Schedule 15CH403J Process Modeling and Simulation

Date of Exam: 01/11/2018 Venue: PGA 202 - Computer Laboratory - II, Department of Chemical Engineering

S. No.	Batch	Time		Total no. of	Pogistor Numbers of the Candidate			
		From	То	Candidates	Register Numbers of the Candidate			
1	1	08:00AM -	- 09:40 AM		RA1511007010001	RA1511007010002	RA1511007010003	RA1511007010004
					RA1511007010012	RA1511007010025	RA1511007010030	RA1511007010031
				22	RA1511007010036	RA1511007010038	RA1511007010040	RA1511007010050
					RA1511007010056	RA1511007010058	RA1511007010063	RA1511007010069
					RA1511007010072	RA1511007010075	RA1511007010077	RA1511007010078
					RA1511007010082	RA1511007010087		
2	2	09:45AM - 11:35 AM			RA1511007010088	RA1511007010090	RA1511007010091	RA1511007010093
					RA1511007010099	RA1511007010101	RA1511007010102	RA1511007010104
			11·25 AM	22	RA1511007010107	RA1511007010116	RA1511007010117	RA1511007010118
			· 11.33 AIVI		RA1511007010121	RA1511007010127	RA1511007010130	RA1511007010132
					RA1511007010139	RA1511007010145	RA1511007010148	RA1511007010150
					RA1511007010152	RA1511007010158		

Note:

Follow the exam timing schedule strictly, Late comers are not allowed

Submit the record when you enter into the laboratory

Possession of mobile phones/un wanted any written material is strictly prohibited

Carry the necessary stationery articles (pencil, scale, eraser and so on)

Borrowing/Exchanging of stationeries during the exam is not allowed

Candidates writing the exam in the hall is not allowed to move out of the hall until the scheduled time for the exam ends

Signature of Course Teacher

Signature of Lab. i/c.

Signature of HoD